

| L Number | Hits | Search Text | DB | Time stamp |
|----------|------|--|------------------------------------|------------------|
| 1 | 44 | microelectronic adj workpiece SAME processing adj stations | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2003/07/02 18:53 |
| 7 | 784 | 204/224R.ccls. | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2003/07/02 18:57 |
| 13 | 34 | 204/224R.ccls. and processing adj stations | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2003/07/02 18:58 |
| 19 | 16 | 204/224R.ccls. and processing adj stations and automatic\$4 | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2003/07/02 19:02 |
| 25 | 6 | 204/224R.ccls. and processing adj stations and automatic\$4 and microelectronic | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2003/07/02 19:02 |
| - | 16 | microelectronic adj workpiece SAME processing adj stations and input?output | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2003/07/02 16:45 |
| - | 9 | microelectronic adj workpiece SAME processing adj stations and input?output and manually | USPAT; US-PGPUB; EPO; JPO; DERWENT | 2003/07/02 16:46 |